

Docket No. 263787US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Hiroshi MASHIMA, et al.

SERIAL NO: 10/518,371

ART UNIT: 1792

FILING DATE: December 28, 2004

EXAMINER: GAMBETTA, KELLY M.

FOR: METHOD FOR PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION AND APPARATUS FOR
PLASMA-ENHANCED CHEMICAL VAPOR DEPOSITION

FEE TRANSMITTAL

- No additional fee is required
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.

The Fee has been calculated as shown below:

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	10 - 20 =	0	x \$52 =	\$0.00
INDEPENDENT CLAIMS	1 - 3 =	0	x \$220 =	\$0.00
<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS (If applicable)			+ \$390 =	\$0.00
<input type="checkbox"/> LATE FILING OF DECLARATION			+ \$130 =	\$0.00
			BASIC FEES	\$0.00
			TOTAL OF ABOVE CALCULATIONS	\$0.00
<input type="checkbox"/> REDUCTION BY 50% FOR FILING BY SMALL ENTITY				\$0.00
<input type="checkbox"/> FILING IN NON-ENGLISH LANGUAGE			+ \$130 =	\$0.00
			TOTAL	\$0.00

- Please charge Deposit Account No. 15-0030 in the amount of \$0.00
 Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of \$0.00.
 The Director is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no payment is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.
 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030.

Submitted by: _____

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